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Docket No.: 8734.254.00-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Jung, Yun Ho

Customer No.: 30827

Application No.: 10/705,891

Confirmation No.: 6104

Filed: November 13, 2003

Art Unit: 1756

For: MASK FOR LASER IRRADIATION AND
APPARATUS FOR LASER
CRYSTALLIZATION USING THE SAME

Examiner: Stephen D. Rosasco

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated February 2, 2006, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.